

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
*(Not for submission under 37 CFR 1.99)*

Application Number		10509431
Filing Date		2005-07-27
First Named Inventor	Short et al.	
Art Unit	1792	
Examiner Name	Padgett, Marianne L.	
Attorney Docket Number	102-679 PCT/US/RCE	

**U.S. PATENTS****Remove**

Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1					

If you wish to add additional U.S. Patent citation information please click the Add button.

**Add****U.S. PATENT APPLICATION PUBLICATIONS****Remove**

Examiner Initial*	Cite No	Publication Number	Kind Code <sup>1</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1					

If you wish to add additional U.S. Published Application citation information please click the Add button

**Add****FOREIGN PATENT DOCUMENTS****Remove**

Examiner Initial*	Cite No	Foreign Document Number <sup>3</sup>	Country Code <sup>2</sup>	Kind Code <sup>4</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	Ts
	1	60238304	JP			Shinohara		

If you wish to add additional Foreign Patent Document citation information please click the Add button

**Add****NON-PATENT LITERATURE DOCUMENTS****Remove**

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	Ts
--------------------	---------	---	----

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number	10509431
Filing Date	2005-07-27
First Named Inventor	Short et al.
Art Unit	1792
Examiner Name	Padgett, Marianne L.
Attorney Docket Number	102-679 PCT/US/RCE

1	DAI et al.; "Surface Modification of Plasma Etching and Plasma Patterning", Journal of Physical Chemistry B (1997), 101(46), pp. 9548-9554	<input type="checkbox"/>
2	YOSHIMURA et al.; "Guidelines for Preparation of Plasma Polymer in View of Surface Functionalization of Solid Materials", Journal of Photopolymer Science and Technology (1996) n 9(2), pp. 225-236	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button [Add](#)

**EXAMINER SIGNATURE**

Examiner Signature	Date Considered
--------------------	-----------------

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> See Kind Codes of USPTO Patent Documents at [www.USPTO.GOV](http://www.USPTO.GOV) or MPEP 901.04. <sup>2</sup> Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>3</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>4</sup> Kind of document by the appropriate symbol as indicated on the document under WIPO Standard ST.16 if possible. <sup>5</sup> Applicant is to place a check mark here if English language translation is attached.